

Beam Test Results of 3D Pixel Detectors Constructed With poly-crystalline CVD diamonds

The RD42 Collaboration

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As a possible candidate for extremely radiation tolerant tracking devices we present a novel detector design - namely 3D detectors - based on poly-crystalline CVD diamond sensors with a pixel readout. The fabrication of recent 3D detectors as well their results in recent beam tests are presented. We measured the hit efficiency and signal response of two 3D diamond detectors with $50 \times 50 \,\mu m$ cell sizes using pixel readout chip technologies currently used at CMS and ATLAS. In all runs, both devices attained efficiencies >98 % in a normal incident test beam of minimum ionising particles. The maximum efficiency observed during the beam tests was 99.2 %.

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1. Introduction

The radiation levels of the High-Luminosity-LHC (HL-LHC) are expected to be a big challenge for the future detectors. By 2028 experiments must be prepared for an instantaneous luminosity of $7.5 \cdot 10^{34}$ cm⁻² s⁻¹. In this environment the innermost tracking layer at a transverse distance of ~ 30 mm to the interaction point will be exposed to a total fluence of $2 \cdot 10^{16} \, n_{eq}/cm^2$ [1]. The expected lifetime of the current planar silicon tracking detectors would be about one year in such an environment.

In this work, we present the test beam measurements of 3D detectors using poly-crystalline Chemical Vapour Deposition (pCVD) diamond, which were fabricated by the CERN RD42 collaboration [2]. Diamond has an average threshold displacement energy of 43 eV/atom [3] which makes it intrinsically radiation tolerant and its band gap of 5.5 eV [4] greatly simplifies the construction of the detectors as well as guarantees negligible leakage currents.

After the doses expected in the HL-LHC, all detector materials will be trap limited with a schubweg, the average drift distance before a free charge carrier gets trapped, below 75 µm [5, 6]. The RD42 collaboration is studying a novel detector design in diamond, namely 3D detectors, to extend the radiation tolerance of diamond to fluences exceeding the HL-LHC doses. This detector design places column-like electrodes inside the detector material. In this detector geometry the drift distance an electron-hole pair must undergo to reach an electrode can be reduced below the schubweg of an irradiated sensor without reducing the number of electron-hole pairs created. The details of the general working principles of 3D detectors may be found in [7].

2. 3D Pixel Detectors

2.1 Fabrication

All devices discussed in this article were constructed with pCVD diamond. The sensors were thin plates with a thickness of $\sim\!500\,\mu m$ and a side length of $\sim\!5$ mm. In order to manufacture the electrodes in diamond, columns were fabricated perpendicular to the large side using a 130 fs laser with a wavelength of 800 nm. After focusing to a 2 μm spot the laser has the energy density to convert diamond into a electrically resistive mixture of different carbon phases [8]. A Spatial Light Modulator (SLM) [9] was used to correct spherical aberrations during fabrication. This helped to achieve the high column yield of $\gtrsim\!99.8\,\%$, a column diameter of 2.6 μm and a resistivity of the columns of the order of $0.1\sim 1\,\Omega\,cm$. The yield was measured by manually counting missing or broken columns and the diameter was optically measured. The columns are not drilled completely through the diamond, but with a gap of 15 μm to the opposite surface to avoid high voltage breakthrough at the operated bias voltages of up to 70 V. The detector was constructed by ganging all bias columns together with a mesh metallisation on one surface and metallising the other surface to connect a small number of readout columns in order to match the pitch of the readout electronics for bump bonding.

The detectors described herein were connected to two different readout chips (ROCs), which is why different bonding processes, as shown in Figures 1, were used. For both of these detectors

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a 3D cell size of $50\,\mu\text{m}\times50\,\mu\text{m}$ was chosen. Since the layout of the ROCs had a different pixel pitch several cells were ganged together by connecting several readout columns with the surface metallisation. Detector 1 was connected to the PSI46digV2.1respin ROC [10] with a 3×2 cell ganging to match the pixel pitch of $150\,\mu\text{m}\times100\,\mu\text{m}$. It was bump bonded to the ROC at the Nanofabrication Lab at the Princeton University [11] with indium. This was achieved by putting equal height indium columns on both ROC and the sensor and then pressing them together without reflow (see Figure 1a). The second detector was connected to the FE-I4B ROC [12] with a 5×1 cell ganging due to the pixel pitch of $250\,\mu\text{m}\times50\,\mu\text{m}$. The bump bonding for this sensor was performed at IFAE-CNM in Barcelona [13, 14] by an adapted process with tin-silver bumps (see Figure 1b).

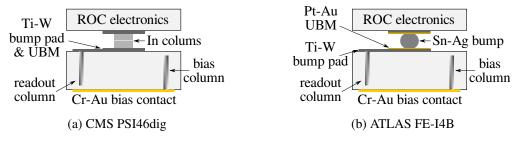


Figure 1: Bump Bonding and metallisation for two different ROCs.

Both devices have \sim 3500 3D cells, where one cell consists of four bias electrodes and one readout electrode in the centre. Since the bias electrodes are shared between the cells, \sim 7200 columns had to be drilled to build such a device. Except for the different readout, the sensors are very similar. Photographs of the assembled 3D detectors on the ROCs are shown in Figure 2.

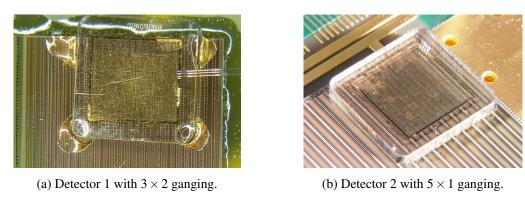


Figure 2: Assembled 3D pixel detectors.

2.2 Results of Detector 1 (3×2)

This detector was tested with pixel telescopes in beam lines at Paul Scherrer Institut (PSI) and the SPS facility at CERN in order to get both measurements at high rates as well as with high tracking resolution. At PSI a beam of 210 MeV/c positive pions was used [15], whereas at CERN the momentum of the hadron beam was 120 GeV/c [16]. The preliminary beam test results show that, relative to a planar silicon device, the efficiency within a selected fiducial area was 99.2%.

Where the hit efficiency was defined as the percentage of hits in the 3D pixel detector when a particle track traversed the detector. This value was measured at both beam test facilities. The fiducial area was selected such as to exclude non-working 3D cells found by visual inspection, which can happen due to broken or missing columns or due to metallisation issues, where the metal is not properly connected to the electrodes. A small discrepancy between a 3D and a fully efficient planar device is partly expected due to the relative inefficiency of the columns themselves. The area of the 3D columns compared to the whole cell is 0.4 %.

Figure 3 shows that the efficiency of the detector plateaus at a voltage of 30 V. This demonstrates that the device already operates well at very low voltages compared to a planar diamond detector. The efficiency at both facilities agrees well, which shows that the detector is independent of the different particle energies and intensities which were used.

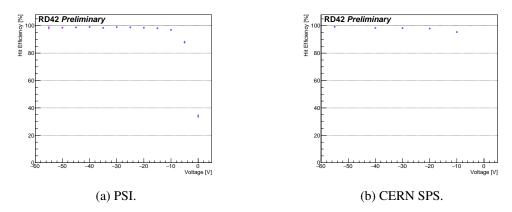


Figure 3: Hit efficiency vs. bias voltage.

The preliminary analysis of the pulse height distribution for the measurements at CERN yields a mean value of \sim 14 ke. The precise pulse height calibration of the ROC is currently being studied.

2.3 Results of Detector 2 (5×1)

This device was solely tested at the CERN SPS beam line H6 with $120\,\text{GeV/c}$ hadrons. The tracking reconstruction was performed using a high resolution beam telescope, with a spatial resolution of 3 μ m at the device under test so that the efficiency could be mapped to the spatial coordinates.

The preliminary analysis yields an efficiency of 98.2% in a contiguous fiducial area. As shown in Figure 4, the detector reaches the same efficiency for all tested voltages. The reason of the lower efficiency compared to detector 1 is still under investigation. Most likely this is caused by issues with the bump bonding or an electrostatic issue. The preliminary pulse height in the fiducial region was ~ 14 ke which is consistent with the result of the first detector. The precise pulse height calibration for the FE-I4B ROC is in the process of being performed.

3. Conclusion

We demonstrated a progress in the development of radiation tolerant particle detectors based on pCVD diamond. The preliminary results show two working prototypes of 3D diamond pixel

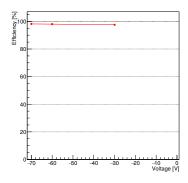


Figure 4: Hit efficiency vs. voltage.

detectors with a cell size of $50 \, \mu m \times 50 \, \mu m$ and a column diameters of $2.6 \, \mu m$. The devices had a total number of $\sim \! 3500 \, cells$ and the efficiency of the column drilling process is above 99.8 %. The first prototypes of small cell 3D diamond pixel detectors read out more charge than any planar pCVD diamond detector. At normal incidence the measured relative hit efficiency of the 3D pixel detectors reached 99.2 % compared to a planar silicon device. In all runs, the tested devices reached efficiencies $> \! 98 \, \%$.

Future test are planned in order to solve the open questions. Tests at non-normal incidence will hopefully show the origin of the missing 0.8 % in efficiency compared to planar silicon. Further investigations of detector 2 will show whether the lower efficiency is due to the bump bonding or electrostatic issues or something else.

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